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Bib Data Sheet

CONFIRMATION NO. 8651

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|---|---|----------------------------------|---|---|
| SERIAL NUMBER 10/060,569 | FILING DATE 01/29/2002 RULE | CLASS 438 | GROUP ART UNIT 1763 | ATTORNEY DOCKET NO. N230500C1 |
| APPLICANTS Migaku Kobayashi, Tokyo, JAPAN; ** CONTINUING DATA ***** THIS APPLICATION IS A CON OF 09/640,959 08/16/2000 <i>now abandoned</i> <i>gag 4-021</i> ** FOREIGN APPLICATIONS ***** JAPAN 230500/1999 08/17/1999 <i>gag 4-021</i> | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/28/2002 | | | | |
| Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged | <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>gag 4-021</i> Examiner's Signature Initials | STATE OR COUNTRY JAPAN | SHEETS DRAWING 12 | TOTAL CLAIMS 20 |
| INDEPENDENT CLAIMS 3 | | | | |
| ADDRESS Darryl G. Walker WALKER & SAKO, LLP Suite 235 300 South First Street San Jose, CA 95113 | | | | |
| TITLE Method of fabricating a semiconductor device | | | | |
| FILING FEE RECEIVED 740 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |